

DOCKET NO: 282362US2PCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :

HISAO IGARASHI, ET AL. : ATTN: APPLICATION DIVISION

SERIAL NO: DECEMBER 7, 2005 :

FILED: 10/559,846 :

FOR: ANISOTROPIC CONDUCTIVE :
CONNECTOR AND WAFER
INSPECTION DEVICE

PRELIMINARY AMENDMENT

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

Prior to a first examination on the merits, please amend the above-identified
application as follows:

Amendments to the Specification begin on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.